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APPLICATION NO.		FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO. 5009		
10/082,955		02/26/2002		Jason Barnabas Langhorn	CTS-2287			
	29184	7590	09/09/2004		EXAM	EXAMINER		
CTS CORPORATION					GEBREMARIAM, SAMUEL A			
	905 W. BLVI ELKHART,		Δ		ART UNIT	PAPER NUMBER	-	
	ELKIIAKI,	114 4051	7		2811			

DATE MAILED: 09/09/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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•		Application No.	4	Applicant(s)						
		10/082,955	!	LANGHORN, JAS	ON BARNABAS					
	Office Action Summary	Examiner	- ,	Art Unit						
		Samuel A Gebre	mariam :	2811						
	The MAILING DATE of this communicate	tion appears on the cover	r sheet with the co	rrespondence ad	dress					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).										
Status										
1)	Responsive to communication(s) filed	on <i>7/1/04</i> .			~					
•	•	This action is non-fin	al.							
3)	,—									
Dispositi	on of Claims									
5)□ 6)⊠ 7)□	 ✓ Claim(s) 25-28 is/are pending in the application. ✓ 4a) Of the above claim(s) is/are withdrawn from consideration. ☐ Claim(s) is/are allowed. ✓ Claim(s) 25-28 is/are rejected. ☐ Claim(s) is/are objected to. ☐ Claim(s) are subject to restriction and/or election requirement. 									
Applicati	on Papers									
9)	The specification is objected to by the E	Examiner.								
10)	☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.									
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).									
11)	Replacement drawing sheet(s) including the The oath or declaration is objected to be	•			• •					
Priority ι	ınder 35 U.S.C. § 119									
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 										
Attachmen	' '	🗖		TO 446						
2) Notice (3) Information	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTC nation Disclosure Statement(s) (PTO-1449 or PT r No(s)/Mail Date	0-948) O/SB/08) 5) 🔲	Interview Summary (F Paper No(s)/Mail Date Notice of Informal Pat Other:	ei.	O-152)					

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 25-28 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hinds EP, 1057779A2 in view of Kainuma et al. U.S. patent No. 6,483,190.

Regarding claim 1, Hinds teaches (figs. 1, 2 and 3) a semiconductor package comprising: a planar low temperature co-fired ceramic substrate having a first (22) and second layer (30) mounted adjacent each other the first layer having a first surface (24) and the second layer having a second surface (23) a micro-machined semiconductor device (40) located adjacent the first surface (24), the micro-machined semiconductor device having a plurality of first pads (37) and an active central area (42), a plurality of ball pads (17) located on the second surface, a plurality of second pads (44) located on the first surface a plurality of vias (25 and 33) extending through the substrate between the first and second surfaces the vias (33) connected to the ball pads (17) and to the first pads (37) a reflowed solder joint (50, col. 4, lines 50-59) located between the first (37) and second pads (44) for electrically connecting the substrate to the semiconductor device the reflowed solder joint formed from a first reflowed solder paste (col. 4, lines 50-57) a solder seal ring (36), located between the micro-machined semiconductor

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device and the first surface around an outer perimeter (fig. 2 and 3) of the substrate for making a hermetic seal between the micro-machined semiconductor device and the substrate (col. 7, lines 45-48) and plurality of solder spheres mounted to the ball pads by a second reflowed solder paste.

Hinds does not explicitly teach a wire bond bump located between the micromachined semiconductor device and the first surface for supporting the micro-machined semiconductor device during assembly.

However Hinds shows in figures 2 and 3 a structure preventing the micromachined semiconductor device from contacting the first surface (24). Furthermore the use of wire bump structures is conventional in the art and also taught by Kainuma (fig. 2b) for protecting a silicon chip (101) using bump structures (113 and 114).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate the bump structures taught by Kainuma in the structure of Hinds in order to protect the micro-machined semiconductor device.

The limitation of ultrasonically deposited wire bonds is considered a product-by-process claim. "[E]ven though product-by process claims are limited by and defined by the process, determination of patentability is based on the product itself. The patentability of a product does not depend on its method of production. If the product in the product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process." *In re Thorpe*, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985).

Furthermore the limitation the wire bond bumps preventing the micro-machined semiconductor device from contacting the top surface during solder reflow is not given patentable weight because, a recitation of the intended use of the claimed invention must result in a structural difference between the claimed invention and the prior art in order to patentably distinguish the claimed invention from the prior art. If the prior art structure is capable of performing the intended use, then it meets the claim. In a claim drawn to a process of making, the intended use must result in a manipulative difference as compared to the prior art. See In re Casey, 152 USPQ 235 (CCPA 1967) and In re Otto, 136 USPQ 458, 459 (CCPA 1963).

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Regarding claim 26, Hinds teaches (figs. 2 and 3) substantially the entire claimed structure of claim 25 above including a plurality of circuit lines (26) located on the first surface (24), the circuit lines connected between vias (20 and 25) and the second pads (44).

Regarding claim 27, Hinds teaches substantially the entire claimed structure of claim 25 above including the substrate does not have a cavity. Since the combined structure of Hinds and Kainuma are the same as the claimed structure, the substrates of the combined structure does not have cavity.

Regarding claim 28, Hinds teaches substantially the entire claimed structure of claim 25 above including wire bond bumps that are formed of gold alloy (Kainuma (col. 5, lines 19-52).

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Response to Arguments

3. Applicant's arguments filed 7/1/04 have been fully considered but they are not persuasive. Applicant argues that the neither nor Kainuma disclose or suggest a semiconductor package that includes a first reflowed solder paste for making an electrical connection between a substrate and a semiconductor device and a wire bond bump located between the micro-machined semiconductor device and the substrate to support the micro-machined semiconductor device during solder reflow. Applicant also argues the combination of Hinds and Kainuma teaches away from the present invention because the combination produces a cavity. As stated in the rejection above the combined structure of Hinds and Kainuma teach the claimed invention. Furthermore the combined structure of Hinds and Kainuma would not introduce a cavity or gap other than the existing gap that is indicated by region (35) in Hinds structure i.e the same kind of gap as the present invention.

Conclusion

4. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

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the advisory action. In no event, however, will the statutory period for reply expire later

than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Samuel A Gebremariam whose telephone number is

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

(571)-272-1653. The examiner can normally be reached on 8:00am-4:30pm.

supervisor, Eddie Lee can be reached on (571) 272-1732. The fax phone number for

the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the

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Business Center (EBC) at 866-217-9197 (toll-free).

SAG

September 2, 2004

EDDIE LEE

SUPERVISORY PATENT EXAMINER

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